

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) BUR920040087US1		Application Number 10/709,793	
				Applicant(s) Andra, et al.			
				Filing Date May 28, 2004		Group Art Unit 2171	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS							
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FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)
MD		Meyuhas, et al., "THE OPERATIONAL LOGIC BEHIND MANAGING A FULLY AUTOMATED 300 mm FEB", Semiconductor Manufacturing, October 2003, pages 152-159	
MD		Girin, et al., "PROCESS CONTROL THROUGH LITHOGRAPHY AUTOMATION", Semiconductor Manufacturing, July 2003, pages 85-90	

EXAMINER /Mahesh Dwivedi/	DATE CONSIDERED 08/14/2006
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.